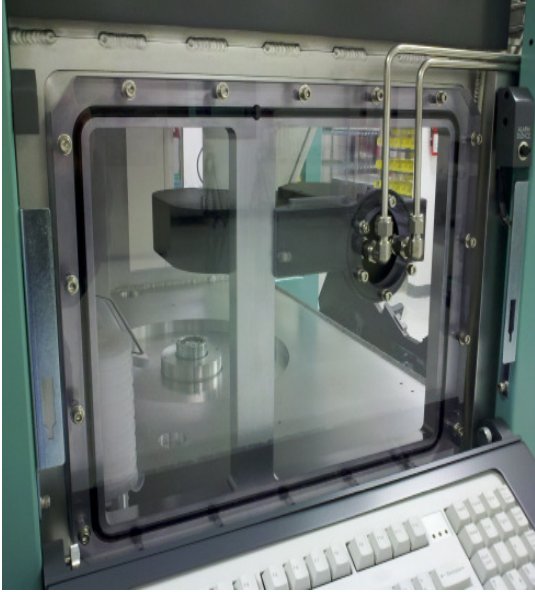


Enhanced View Port Window



The Enhanced View Port Window upgrade reduces the chance for wafer scrap attributed to incorrect C1 cool station and robot setup and promotes an optimal means for troubleshooting system wafer handling issues.

The Enhanced View Port Window is available for C1 systems that use a wafer cool station. The upgrade is a direct drop in replacement for the original aluminum plate which replaces the plate with a large Plexiglas Window. The aluminum plate has a very small window for viewing the load lock. With the upgrade to the large Plexiglas Window, visibility is significantly improved and makes robot setup and troubleshooting much easier helping to eliminate errors that can occur when maintaining the handling system.



Upgrade Benefits

- Larger viewing area.
- Reduces the time needed to setup robot pin search and cool station coordinates
- Easier to view robot movement during trouble-shooting of wafer handling issues
- Potential reduction in system down time due to the simplification of the wafer handling setup
- Potential reduction in wafer scrap due to incorrect system robot setup

CONCEPT ONE PRODUCT UPGRADES

Enhanced Side View Port



Concept Parts Solutions (CPS) is fully authorized and approved by Lam Research Inc.; CPS is the only company licensed to provide original OEM parts, upgrades, and service for the Novellus Concept One and GaSonic Legacy Asher platforms.

For pricing, quotations and ordering guidance, or for additional information, please contact:

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